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APPLICANTS

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** CONTINUING DATA ***** none

** FOREIGN APPLICATIONS ***** SDI
 JAPAN 2002-315882 10/30/2002

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Harold Kane</i> SDI Examiner's Signature Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 4	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 2
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TITLE

Semiconductor device fabrication method using oxygen ion implantation

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